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CLAIMS

- 1. A method for preparing a substrate having a patterned surface, comprising:
- (a) providing a substrate having a surface to which molecular moieties can covalently bind;
- (b) identifying predetermined regions on the substrate surface that correspond to a desired surface pattern;
- (c) derivatizing the substrate surface by contacting the predetermined regions of the surface with a molecular moiety A-B, wherein A is a reactive terminus and B is an inert segment, under conditions effective to bring about covalent binding of the molecular moiety A-B to the surface through the reactive terminus A, thus providing surface-bound B segments in the predetermined regions with the remainder of the surface comprised of unmodified regions;
- (d) contacting the derivatized substrate surface provided in step (c) with a molecular moiety A'-L-C, wherein A' is a reactive terminus and may or may not be the same as A, L is a linker, and C is a molecular segment terminating in a functional group, under conditions effective to bring about covalent binding of the molecular moiety A'-L-C to the unmodified regions of the substrate surface through the reactive terminus A', whereby a modified substrate surface is provided having surface-bound B segments in the predetermined regions and surface-bound C segments on the remainder of the surface; and

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- (e) contacting the modified surface provided in step (d) with a polymerizable composition under conditions effective to result in the binding of a polymer to the functional groups of the surface-bound C segments.
 - 2. The method of claim 1, wherein the substrate is metallic.
 - 3. The method of claim 1, wherein the substrate is comprised of a metal oxide.
 - 4. The method of claim 1, wherein the substrate is silicon-containing.
 - 5. The method of claim 1, wherein the substrate is polymeric.
- 6. The method of claim 1, wherein step (b) is conducted by stamping the substrate surface with a stamp coated with the molecular moiety A-B in a pattern that identical to the pattern defined by the predetermined regions on the substrate surface.
- 7. The method of claim 1, wherein the surface-bound B segments provided in step (c) comprise a self-assembled monolayer.
- 8. The method of claim 1, wherein the surface-bound -L-C segments provided in step (d) comprise a self-assembled monolayer.

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- 9. The method of claim 1, wherein the polymerization composition is comprised of reactive monomers.
- 10. The method of claim 1, wherein the polymerization composition is comprised of an intact polymer capable of binding to the functional group of the molecular segment C.
- 11. The method of claim 1, wherein A is selected from the group consisting of -OH, -SH, -NH₂, -CONH₂, -COOH, -SO₃H, -CN, -PO₃H, -SiCl₃, -SiR₂Cl, -SR and -SSR wherein R is alkyl or aryl.
- 12. The method of claim 1, wherein A' is selected from the group consisting of -OH, -SH, -NH₂, -CONH₂, -COOH, -SO₃H, -CN -OH, -SH, -NH₂, -PO₃H, -SiCl₃, -SiR₂Cl, -SR and -SSR wherein R is alkyl or aryl.
- 13. The method of claim 1, wherein B is hydrocarbyl of 1 to 20 carbon atoms containing 0 to 6 ether linkages.
- 14. The method of claim 13, wherein B is saturated alkyl containing 1 to 15 carbon atoms and 0 to 4 ether linkages.

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- 15. The method of claim 1, wherein L is hydrocarbylene of 1 to 20 carbon atoms containing 0 to 6 ether linkages.
- 16. The method of claim 15, wherein L is saturated alkylene containing 1 to 15 carbon atoms and 0 to 4 ether linkages.
- 17. The method of claim 1, wherein C is selected from the group consisting of -OH, -NH₂, -COOH, -SO₃H, -CN, alkoxyamine, azo, peroxide, halide and sulfonyl halide.
 - 18. A method for etching a substrate surface, comprising:
 - (a) identifying predetermined regions on the surface to be protected from etching;
- (b) contacting the predetermined regions with a molecular moiety A'-L-C, wherein A' is a reactive terminus, L is a linker, and C is a molecular segment terminating in a functional group, under conditions effective to bring about covalent binding of the molecular moiety A'-L-C to the surface through the reactive terminus A', thus providing surface-bound -L-C segments in the predetermined regions with the remainder of the surface comprised of unmodified, exposed regions; and
- (d) contacting the surface derivatized in step (b) with a polymerizable composition under conditions effective to result in the binding of a polymer to the functional groups of the surface-bound C segments; and

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(d) contacting the surface modified in step (c) with a reagent that is selected to degrade the unmodified, exposed regions of the surface but that is inert with respect to the surface-bound polymer.

19. The method of claim 18, further including, after step (e), removing the surface-bound -L-C groups and the polymer to uncover the predetermined regions of the surface.

- 20. The method of claim 18, wherein the surface-bound -L-C segments provided in step (c) comprise a self-assembled monolayer.
- 21. The method of claim 18, wherein the polymerization composition is comprised of reactive monomers.
- 22. The method of claim 18, wherein the polymerization composition is comprised of an intact polymer capable of covalent attachment to the functional group of the molecular segment C.
 - 23. The method of claim 18, wherein the surface is electrically conductive.
 - 24. A substrate having a patterned surface, comprising:
 - (a) a substrate having a surface with predetermined regions that correspond to a

desired surface pattern and remaining regions that correspond to the inverse of the desired surface pattern;

- (b) a first self-assembled monolayer of a first molecular moiety covalently bound to the surface within the predetermined regions; and
 - (c) a polymeric overlayer comprised of a polymer bound to the first molecular moiety.
- 25. The substrate of claim 24, further comprising: (d) a second self-assembled monolayer of a second molecular moiety bound to the surface in the remaining regions.
 - 26. The substrate of claim 24, wherein the substrate surface is metallic.
- 27. The substrate of claim 24, wherein the substrate surface is comprised of a metal oxide.
 - 28. The substrate of claim 24, wherein the substrate surface is silicon-containing.
 - 29. The substrate of claim 24, wherein the substrate surface is polymeric.